

GP 2811
Attorney's Docket No.: 07977/192001/US3444

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani, et al. Art Unit : 2811
Serial No.: 08/958,568 Examiner : S. Hu
Filed : October 28, 1997
Title : SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

Commissioner for Patents
Washington, D.C. 20231

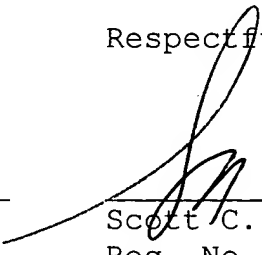
TRANSMITTAL LETTER

Correspondence relating to this application is enclosed.
The required fees are computed below. Please apply any charges
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Total Claims	53	-	66	=	0	\$0
Independent	11	-	11	=	0	\$0
TOTAL FEE DUE						\$0

Respectfully submitted,

Date: 7/6/00



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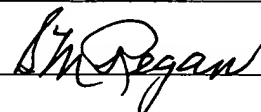
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Assistant Commissioner for Patents
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RESPONSE TO RESTRICTION REQUIREMENT

In response to the Official Action mailed June 6, 2000,
applicants elect the invention of claims 60-62, and 72,
election is made without traverse.

In the Claims:

Please cancel claims 13, 14, 19-28, 56-59, and 63-72.

Please add the following new claims.

--73. (New) A semiconductor device comprising:

a substrate;

a source region and a drain region provided over said
substrate;

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